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	INFORMATION	DISC	OSURE	Application Number	10/594,495	
	STATEMENT BY	Y APF	LICANT	Filing Date	03/29/2005	SED S
Date Submitted: September 22, 2009			or 22 2000	First Named Inventor	Tadahiro OHMI	2 2 2000
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	(use as many shee	ts as	necessary)	Examiner Name	Nguyen, Vu Anh	(2) E
Sheet	1	of	1	Attorney Docket Number	039262-0163	PADEMARK

U.S. PATENT DOCUMENTS					
Examin	Cite _	Document Number	Publication Date	Name of Patentee or Applicant of	Pages, Columns, Lines, Where Relevant
er Initials*	No.1	Number-Kind Code ² (if known)	MM-DD-YYYY	Cited Document	Passages or Relevant Figures Appear

	UNPUBLISHED U.S. PATENT APPLICATION DOCUMENTS					
Examiner Initials*	Cite No. ¹	U.S. Patent Application Document Serial Number-Kind Code ² (if known)	Filing Date of Cited Document MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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			FOREIGN PATENT	DOCUMENTS		
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ Number ⁴⁻ Kind Code ⁵ (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Documents	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
	B1	JP 2004-010990A	01-15-2004	SONY CORP.		Α
	B2	WO 03/080893 A1	10-02-2003	AIXTRON AG		Α
	В3	WO 03/020999 A1	03-13-2003	THE TRUSTEES OF PRINCETON UNIVERSITY		

	NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ⁶			
	B4	M. A. BALDO et al., "Low Pressure Organic Vapor Phase Deposition of Small Molecular Weight Organic Device Structures," Materials Research Society Symposium Proceedings, Materials Research Society, Vol. 488, December 1, 1997, XP001030436, pp. 587-592.				

Examiner		Date	
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